



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#7/Be-RAM-4
PATENT
6/4/02
JNO

In re application of: Satya et al

Application No.: 09/648,095

Attorney Docket No.: KLA1P016F

Examiner: Not assigned

Group: 2858

Title: CHEMICAL MECHANICAL POLISHING
TEST STRUCTURES AND METHODS FOR
INSPECTING THE SAME

CERTIFICATE OF MAILING
I hereby certify that this correspondence is being deposited with the
United States Postal Service as First Class Mail to: Commissioner for
Patents, Washington, DC 20231 on April 16, 2002.

Signed: Natalie Morgan
Natalie Morgan

PRELIMINARY AMENDMENT

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Please enter the following amendments prior to examination of the above identified
application.

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IN THE SPECIFICATION:

At page 1, line 7, please insert the following:

C1
This application is related to concurrently filed U.S. patent applications having
application numbers 09/648,093, 09/648,380 09/648,109, 09/648,094, 09/648,212, ,09/648,381,
09/648,096, 09/648,379 and 09/648,092.